MATG-401US **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No:

To Be Assigned

Applicant:

Ming Li et al. Herewith

Filed: Title:

ULTRAFAST LASER DIRECT WRITING METHOD FOR MODIFYING EXISTING

MICROSTRUCTURES ON A SUBMICRON SCALE

TC/A.U.:

To Be Assigned

Examiner:

To Be Assigned

Docket No.:

MATG-401US

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98 and to the duty of disclosure set forth in 37 C.F.R. § 1.56, the Examiner in charge of the above-identified application is requested to consider and make of record the references listed on the PTO 1449 (RP) submitted herewith. A copy of each of the listed references is also enclosed.

Although the information submitted herewith may be "material" to the Examiner's consideration of the subject application, this submission is not intended to constitute an admission that such information is "prior art" as to the claimed invention.

In accordance with 37 C.F.R. § 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made.

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This Information Disclosure Statement is being filed concurrently with the abovereferenced application.

Respectfully submitted,

Kenneth N. Nigon, Reg. No. 31,549 Lowell L. Carson, Reg. No. 48,548 Attorney(s) for Applicant(s)

KNN/tmb

Enclosures: PTO Form 1449

(2) References

Dated: March 1, 2004

P.O. Box 980 Valley Forge, PA 19482 (610) 407-0700

The Commissioner for Patents is hereby authorized to charge payment to Deposit Account No. 18-0350 of any fees associated with this communication.

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March 1, 2004

I hereby certify that this paper and fee are being deposited, under 37 C.F.R. § 1.10 and with sufficient postage, using the "Express Mail Post Office to Addressee" service of the United States Postal Service on the date indicated above and that the deposit is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

PTO/SB/08b (08-03) (AW 10/2003) Approved for use through 6/30/2006. OMB 0651-0031 U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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	Substitute for Form 1449B/PTO	Complete if Known		
		Application Number	To Be Assigned	
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)	Filing Date	Herewith	
		First Named Inventor	Ming Li et al.	
		Art Unit	To Be Assigned	
		Examiner Name	To Be Assigned	
	SHEET 1 of 1	Attorney Docket No.	MATG-401US	

NON-PATENT LITERATURE DOCUMENTS						
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²			
	1.	MING LI ET AL., Nanostructuring in submicron-level waveguides with femtosecond laser pulses, Optics Communications, Elsevier Science B.V., September 2002, (5 pgs.)				
- "	2.	MING LI ET AL., Ultra-precision machining using fs fast Laser: An application for Photonic Crystal fabrication, Fs Ultra-maching Workshop, March 5, 2003, (53 pgs.)				
	i					
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Examiner Signature		Date Considered				

'Applicant's unique citation designation number (optional).

2Applicant is to place a check mark here if English language translation is attached.

The collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application from to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.